

Electronic Patent Application Fee Transmittal

Application Number:	09212726			
Filing Date:	15-Dec-1998			
Title of Invention:	Semiconductor processing methods of chemical vapor depositing SiO2 on a substrate			
First Named Inventor:	KLAUS F. SCHUEGRAF			
Filer:	Jennifer J. Taylor/Jaime White			
Attorney Docket Number:	M122-1098			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$0 paid	1252	1	450	450

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				450